



RESPONSE UNDER 37 C.F.R. § 1.116 **EXPEDITED PROCEDURE - EXAMINING GROUP 1700**

PATENT

I hereby certify that on the date specified below, this correspondence is being deposited with the United States Postal Service as first-class mail in an envelope addressed to Mail Stop AF, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 09/915,658

Confirmation No.

: 9163

Applicants: Gundu M. Sabde and Whonchee Lee

: July 25, 2001

Attorney Docket No.: 500163.04

: 1765 Art Unit

Customer No.

: 27,076

Examiner: Kin-Chan Chen

Title

Filed

: METHODS AND APPARATUSES FOR PLANARIZING MICROELETRONIC

SUBSTRATE ASSEMBLIES

Mail Stop AF Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

RESPONSE UNDER 37 C.F.R. § 1.116

Sir:

Applicants acknowledge receipt of the Office Action dated April 26, 2004.

Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 5 of this paper.

Do not enter.